

GAS FLOATED WORKPIECE SUPPORTING APPARATUS AND NONCONTACT WORKPIECE
SUPPORT METHOD

[Document Name] Abstract

[Abstract]

[Solution] A gas upward ejector 2B ejecting gas upward, and a gas downward ejector 2A located at an upper side from the gas upward ejector 2B and ejecting gas downward are included, the gas downward ejector 2A is installed at a position where the gas downward ejector 2A ejects the gas downward from above the plate-shaped workpiece 100 to apply pressure, to the plate-shaped workpiece 100 that is floated and supported by the gas ejected from the gas upward ejector 2B, and it is made possible to make a floating amount uniform and support the plate-shaped workpiece with high flatness at a time of floating and supporting the plate-shaped workpiece.

[FIG. 1]